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**Confirmation Letter** 

To, Harpinder Singh Sandhu Published in : Volume 6 | Issue 1 | 2019-01-05



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research .

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

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